

<b>Notice of References Cited</b>	Application/Control No. 10/083,878	Applicant(s)/Patent Under Reexamination TU, XIANG ZHENG	
	Examiner Michelle R. Connelly-Cushwa	Art Unit 2874	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-5,963,682	10-1999	Dorschner et al.	385/16
	B	US-6,163,635	12-2000	Helble, Robert	385/19
	C	US-6,408,120	06-2002	Dautartas, Mindaugas Fernand	385/52
	D	US-2002/0154854	10-2002	Tayebati et al.	385/18
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Toshiyoshi et al., "Electrostatic Micro Torsion Mirrors for an Optical Switch Matrix", Journal of Microelectromechanical Systems Vol. 5, No. 4, December 1996, pages 231-237.
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.